

(12)

(51) Int. Cl.⁶: H01L 41/09

(22) Date of filing: 11.09.1995

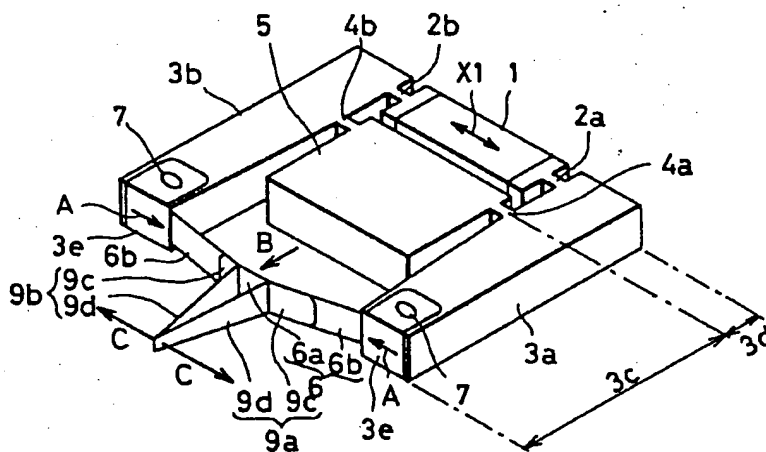
(72) Inventor: Sano, Mitsunori
Minato-ku, Tokyo (JP)

(74) Representative: Glawe, Delfs, Moll & Partner
Patentanwälte
Postfach 26 01 62
D-80058 München (DE)

(57) With reference to Fig. 2, elongation of a piezoelectric element is enlarged by the lever arms (3a, 3b) by the principles of the lever and fulcrum. The thus enlarged elongation is further enlarged by a beam (6) by the principle of buckling. Clampers (9a, 9b) extending at an angle from an axis along which buckling of the beam (6) occurs open and close in accordance with the motion of the beam (6). When the clampers (9a, 9b) open or close, the elongation of the piezoelectric element (1) is

further enlarged. Thus, the piezoelectric clamp device in accordance with the invention uses only one beam (6) in comparison with prior piezoelectric clamp devices using two beams. The use of only one beam (6) reduces a load to be exerted on the lever arms (3a, 3b) to thereby enlarge output elongation of the piezoelectric element (1). In addition, the pair of claspers (9a, 9b) have a function of enlarging the elongation of the piezoelectric element (1).

FIG. 2



EP 0 704 916 A1

Description

BACKGROUND OF THE INVENTION**FIELD OF THE INVENTION**

The invention relates to a piezoelectric clamp device provided with elongation enlarging mechanism by which elongation of a piezoelectric element is enlarged and an object is clamped between a pair of clampers utilizing the enlarged elongation of the piezoelectric element, and more particularly to a piezoelectric clamp device provided with elongation enlarging mechanism comprising a lever arm enlarging elongation of a piezoelectric element utilizing the principles of the lever and the fulcrum and a beam further enlarging the elongation enlarged by the lever arm utilizing the principle of buckling.

DESCRIPTION OF THE RELATED ART

A piezoelectric clamp device is a device in which elongation of a piezoelectric element generated by a voltage applied to the piezoelectric element is transmitted to a pair of clampers for making the clampers open or close to thereby clamp an object between the clampers. A piezoelectric clamp device is divided into two groups: one belonging to a first group has a bimorph type piezoelectric element which is one of composite elements, such as one suggested in Japanese Unexamined Patent Public Disclosure No. 1-321170, and one belonging to a second group has a simple piezoelectric element such as a single plate type piezoelectric element and a laminated type piezoelectric element. The second type piezoelectric clamp device has an advantage of having a higher electrical and mechanical energy conversion efficiency than that of the first type piezoelectric clamp device.

However, the second type piezoelectric element has a demerit of smaller elongation than that of the first type piezoelectric element. Accordingly, a piezoelectric clamp device including the second type piezoelectric element as a driver has to have elongation enlarging mechanism for enlarging elongation of a piezoelectric element generated when a voltage is applied to the piezoelectric element. Such a piezoelectric clamp device having elongation enlarging mechanism has been suggested in Japanese Unexamined Patent Public Disclosures Nos. 5-305574, 1-198037 and 2-68942. All of the piezoelectric clamp devices suggested in the Disclosures include a lever arm for enlarging elongation of a piezoelectric element utilizing the principles of the lever and the fulcrum. In particular, the piezoelectric clamp device suggested in No. 5-305574 further includes a beam for further enlarging elongation of a piezoelectric element enlarged by the lever arm, utilizing the principle of buckling of a beam, in addition to a lever arm. Accordingly, the piezoelectric clamp device suggested in No. 5-305574 has a greater elongation enlargement ratio measured from a piezoelectric element to a distal end of clampers than that of the piezoelectric clamp devices suggested in the other two Disclosures, and hence provides greater opening and closing stroke of clampers.

Fig. 1 illustrates the piezoelectric clamp device suggested in Japanese Unexamined Patent Public Disclosure No. 5-305574. In the illustrated piezoelectric clamp device, each of a pair of lever arms 3a and 3b is connected to a side of a substrate 5 through a first hinge 4a and 4b. Between one ends of the lever arms 3a and 3b is interposed a piezoelectric element 1 through second hinges 2a and 2b. Between the other ends of the lever arms 3a and 3b are bridged a pair of beams 16a and 16b. Each of the beams 16a and 16b is fixedly secured to the other ends of the lever arms 3a and 3b by means of rivets 7. Each of the beams 16a and 16b is provided at a central portion thereof with a clasper 19a and 19b which extends perpendicularly to and on a level with each of the beams 16a and 16b, respectively.

In operation, by applying a driver voltage to the piezoelectric element 1, the piezoelectric element 1 generates a strain or elongation in a direction indicated with an arrow X1. The thus generated elongation is transmitted to ends of the lever arms 3a and 3b through the second hinges 2a and 2b, and then enlarged by the principles of the lever and the fulcrum. In this case, the first hinges 4a and 4b of the lever arms 3a and 3b work as fulcrums. The thus enlarged elongation is transmitted to other ends of the lever arms 3a and 3b, thereby the lever arms 3a and 3b being displaced in a direction indicated with an arrow X2. The displacement of the other ends of the lever arms 3a and 3b causes buckling on the beams 16a and 16b to occur. Thus, the central portions of the beams 16a and 16b are displaced in a direction indicated with an arrow X3, that is, the beams 16a and 16b are displaced so that they come close to each other. As a result, the claspers 19a and 19b horizontally secured to the central portions of the beams 16a and 16b, respectively, come to contact with each other, thereby the claspers 19a and 19b closing. When application of a driver voltage to the piezoelectric element 1 is ceased, the elongation of the piezoelectric element 1 is no longer generated. Hence, the beams 16a, 16b and the lever arms 3a, 3b are displaced in a direction opposite to the directions X3 and X2, respectively, thereby the clasper 19a and 19b opening.

As mentioned above, since the piezoelectric clamp device illustrated in Fig. 1 includes the lever arm for enlarging elongation of the piezoelectric element, and further the beam for further enlarging the elongation enlarged by the lever arm utilizing the principle of buckling of a beam, the piezoelectric clamp device can provide greater open and close stroke to the claspers than that of the prior piezoelectric clamp devices having the lever arms only. According to the

Disclosure No. 5-305574, by using as the piezoelectric element 1 a layer-laminated type piezoelectric element providing 7 μm elongation and also using elongation enlargement mechanism comprising lever arms and beams and having an enlargement ratio of 27, it is possible to obtain displacement of 190 μm in each of the clampers, and hence open and close stroke of 380 μm in the clampers.

As mentioned earlier, the Disclosure No. 5-305574 provides a piezoelectric clamp device which has a greater electrical and mechanical energy conversion efficiency, has a greater clamp force between the clampers, and further has greater stability in open and close stroke and clamp force than those of a piezoelectric clamp device having a bimorph type piezoelectric element. In addition, the piezoelectric clamp device can have greater open and close stroke than that of the prior piezoelectric clamp devices having the lever arms only.

However, in the piezoelectric clamp device suggested in the Disclosure No. 5-305574, each of the clampers 19a and 19b extends horizontally from each of the beams 16a and 16b, respectively, that is, each of the clampers 19a and 19b extends perpendicularly to a direction in which the beams 16a and 16b generates displacement thereof. Hence, the displacement of each of the clampers 19a and 19b is equal to the displacement of each of the beams 16a and 16b. Thus, the open and close stroke of the clampers is determined only by an enlargement ratio of the elongation enlargement mechanism. In order to obtain greater open and close stroke of the clampers, it is necessary to use a piezoelectric element providing longer elongation, apply a greater voltage to a piezoelectric element, or increase an enlargement ratio of the lever arms. However, these may deteriorate reliability and portability of a clamp device. In addition, the piezoelectric clamp device illustrated in Fig. 1 needs the two beams 16a and 16b for enlarging the output displacement of the lever arms 3a and 3b. Hence, the piezoelectric clamp device cannot avoid from being complicated in structure, and in addition, since a load against elongation enlargement action of the lever arms is large, an elongation enlargement ratio provided by the lever arms has to be deteriorated.

SUMMARY OF THE INVENTION

It is an object of the present invention to provide a piezoelectric clamp device which increases an elongation enlargement ratio and thereby provides a greater open and close stroke of clampers than that of the prior piezoelectric clamp devices.

The invention provides a piezoelectric clamp device comprising (a) a piezoelectric element to be elongated in a direction in accordance with a voltage applied thereto, (b) arms for enlarging elongation of the piezoelectric element by the principles of the lever and fulcrum, (c) beams for further enlarging the elongation of the piezoelectric element enlarged by the arms, by the principle of buckling, and (d) a pair of clampers attached to the beams in facing relation for opening and closing in accordance with motion of the beams, the piezoelectric clasper characterized by (A) a single beam in place of the beams to reduce a load to be exerted on the arms when the arms displace due to the elongation of the piezoelectric element, and (B) the clampers extending at an angle from an axis along which buckling of the beam occurs, the clampers further enlarging the elongation of the piezoelectric element.

The invention further provides a piezoelectric clamp device comprising (a) a substrate having high rigidity and at least two sides facing to each other, (b) a pair of lever arms each of which is connected to the side of the substrate through a hinge which partitions the lever arms into a longer portion and a shorter portion, (c) a piezoelectric element connected at opposite ends thereof to the shorter portions of the lever arms through a hinge, (d) beams fixedly connected at opposite ends thereof to the longer portions of the lever arms, and (e) a pair of clampers attached to the beams in facing relation for opening and closing in accordance with motion of the beams, the piezoelectric clasper characterized by (A) a single beam, substituted for the beams, to reduce a load to be exerted on the arms when the arms displace due to the elongation of the piezoelectric element, the beam extending in a direction A in which the longer portions of the lever arms displace, and (B) the clampers extending at an angle from an axis along which buckling of the beam occurs, the clampers being attached to the beam so that the clampers open and close in said direction A, the clamps further enlarging the elongation of the piezoelectric element.

The beam is preferably bent in a direction B in which buckling of the beam occurs. When the beam is designed to be bend in the direction B, the beam is composed of a strip comprising a flat zone disposed at the center thereof and in parallel with the direction A and inclined zones disposed at opposite sides of the flat zone. Each of the clampers is to be attached to each of the inclined zones.

Herein, the angle which each of the clampers forms between itself and an axis along which buckling of the beam occurs is defined as an angle formed between the beam and an outer surface of the clampers. If the clampers are designed to extend in the direction B, the angle is determined to be greater than 90 degrees, while if the clampers are designed to extend in a direction opposite to the direction B, the angle is determined to be smaller than 90 degrees.

As having been described, the invention reduces the number of a beam to one (1) in a piezoelectric clamp device including lever arms for enlarging elongation of a piezoelectric element by the principles of the lever and fulcrum, beams for enlarging output displacement of the lever arms by the principle of buckling, and a pair of clampers which are secured to the beams and open and close in accordance with motion of the beams. The use of a single beam reduces a load to be exerted on the lever arms to thereby increase elongation of a piezoelectric element. Furthermore, by disposing the

claspers so that the claspers extend at an angle from an axis along which bucking of the beam occurs, and open and close in a direction in which bucking of the beam occurs, the output displacement of the lever arms can be enlarged, and hence the open or close stroke of the claspers can be enlarged.

The open and close stroke of the claspers is adjusted as desired by appropriately determining a length of the claspers and an angle at which the claspers are attached to the beam. In addition, since a single beam is to be used, the structure of the piezoelectric clamp device can be made simple. The use of a lamination type piezoelectric element ensures a down-scaled clamp device providing greater elongation than that of other type piezoelectric elements.

The above and other objects and advantageous features of the present invention will be made apparent from the following description made with reference to the accompanying drawings, in which like reference characters designate the same or similar parts throughout the drawings.

BRIEF DESCRIPTION OF THE DRAWINGS

Fig. 1 is a perspective view illustrating a conventional piezoelectric clamp device having elongation enlargement mechanism.

Fig. 2 is a perspective view illustrating a piezoelectric clamp device in accordance with the first embodiment of the present invention.

Fig. 3 illustrates how the beam and the claspers displace of the first embodiment when a driver voltage is applied thereto (broken line) and when no driver voltage is applied thereto (solid line).

Fig. 4 illustrates a variation of the first embodiment illustrated in Fig. 2.

Fig. 5 is a perspective view illustrating a piezoelectric clamp device in accordance with the second embodiment of the present invention.

Fig. 6 illustrates how the beam and the claspers displace of the second embodiment when a driver voltage is applied thereto (broken line) and when no driver voltage is applied thereto (solid line).

DESCRIPTION OF THE PREFERRED EMBODIMENTS

Preferred embodiments in accordance with the present invention will be explained hereinbelow with reference to drawings.

Fig. 2 illustrates a piezoelectric clamp device in accordance with the first embodiment of the present invention. A piezoelectric element 1, which generates elongation in accordance with a voltage applied thereto, is attached to thin T-shaped first hinges 2a and 2b at their flat surfaces through an adhesive such as epoxy resin. The first hinges 2a and 2b are connected to lever arms 3a and 3b. The first hinges 2a and 2b transmit elongation of the piezoelectric element 1 to the lever arms 3a and 3b. The lever arms 3a and 3b have thin second hinges 4a and 4b, respectively. The second hinges 4a and 4b are connected to a substrate 5 at its opposite sides. Each of the second hinges 4a and 4b partitions each of the lever arms 3a and 3b into a longer portion 3c and a shorter portion 3d. The above mentioned first hinges 2a and 2b are connected to the shorter portions 3d of the lever arms 3a and 3b. The second hinges 4a and 4b serve as fulcrums when the lever arms 3a and 3b work to transmit the elongation of the piezoelectric element 1 to a later mentioned beam 6. When the lever arms 3a and 3b transmit the elongation of the piezoelectric element 1 to the beam 6, the longer portions 3c of the lever arms 3a and 3b displace in a direction indicated with an arrow A in Fig. 2. Namely, the lever arms 3a and 3b displace so that they come close to each other. The first hinges 2a and 2b, the second hinges 4a and 4b, the lever arms 3a and 3b and the substrate 5 are integrally formed of high rigidity material such as SUS 304 and 42 Ni-Fe alloy.

Between ends of the longer portions 3c of the lever arms 3a and 3b is bridged a beam 6. The beam 6 is made of metal having resiliency such as phosphor bronze, and is formed by press-punching and bending. The beam 6 is fixed to the lever arms 3a and 3b through rivets 7.

The beam 6 is configured to be bent in a direction indicated with an arrow B in which bucking of the beam 6 occurs. Specifically, the beam 6 is composed of a strip which comprises a flat portion 6a disposed at the center thereof and in parallel with the direction A, and inclined portions 6b disposed at opposite sides of the flat portion 6a.

On the inclined portions 6b of the beam 6 are secured a pair of nearly L-shaped claspers 9a and 9b in facing relation. Each of the claspers 9a and 9b consists of a shorter portion 9c and a longer portion 9d. The claspers 9a and 9b are fixed to the inclined portions 6b of the beam 6 by an adhesive or welding. The longer portions 9d of the claspers 9a and 9b extend from the beam 6 in a direction almost the same as the direction B. The longer portions 9d forms an angle α with the shorter portions 9c and hence the beam 6 (see Fig. 3). In the illustrated embodiment, the angle α is determined to be greater than 90 degrees. Thus, as illustrated in Fig. 2, the claspers 9a and 9b comes to contact with each other at distal ends thereof.

In operation, a driver voltage is first applied to the piezoelectric element 1 to generate elongation in a direction indicated with an arrow X1. The elongation is transmitted to the lever arms 3a and 3b through the first hinges 2a and 2b. The lever arms 3a and 3b enlarges the thus transmitted elongation based on the principles of the lever and fulcrum

wherein the second hinges 4a and 4b works as fulcrums. The thus enlarged elongation is output from the distal ends of the longer portions 3c of the lever arms 3a and 3b as swing displacement of the lever arms 3a and 3b, and is transmitted to the beam 6. The swing displacement of the lever arms 3a and 3b exerts compressive load longitudinally on the beam 6 through the opposite ends of the beam 6. As a result, the buckling of the beam 6 occurs in the direction B. Thus, the displacement of the distal ends of the longer portions 3c of the lever arms 3a and 3b is enlarged based on the principle of buckling of a beam, and transformed to displacement of the flat portion 6a of the beam 6 in the direction B.

As the beam 6 displaces in the direction B, distal ends of the claspers 9a and 9b fixed at the inclined portions 6b of the beam 6 displace in a direction indicated with an arrow C. Namely, the claspers 9a and 9b displace so that they part away from each other, or they open. Herein, the displacement of the claspers 9a and 9b corresponds to enlarged displacement of the flat portion 6a of the beam 6 in the direction B.

Fig. 3 illustrate motion of the beam 6 and the claspers 9a and 9b as viewed from the top. As illustrated with a solid line, the beam 6 and the claspers 9a, 9b do not generate any displacement when no driver voltage is applied to the piezoelectric element 1. On the other hand, as illustrated with a broken line, the beam 6 is displaced due to the buckling and accordingly the claspers 9a and 9b open when a driver voltage is applied to the piezoelectric element 1. When a driver voltage is applied to the piezoelectric element 1, the beam 6 is longitudinally compressed at opposite ends thereof in the direction A, and thus the flat portion 6a of the beam 6 is displaced in the direction B with a length thereof remaining unchanged. Herein, angles and lengths are defined as follows.

L_L : a length of the inclined portions 6b of the beam 6

$2L_H$: a length of the flat portion 6a of the beam 6

β_0 : an angle formed between the inclined portions 6b of the beam 6 and an X axis when no driver voltage is applied to the piezoelectric element 1

L_A : a length of the longer portions 9d of the claspers 9a and 9b

α : an angle formed between the longer portion 9d and the shorter portion 9c of the beam 6

β : an angle formed between the inclined portions 6b of the beam 6 and an X axis when a driver voltage is applied to the piezoelectric element 1

D_Y : a displacement of the flat portion 6a of the beam 6 in the direction B

D_X : a displacement of each of the distal ends of the longer portions 9d of the claspers 9a and 9b in the X axis direction

Thus, a ratio of the displacement D_Y of the beam 6 to the displacement D_X of the clasper 9a or 9b, namely, an enlargement ratio n of the claspers 9a and 9b is calculated by the following equation.

$$n = D_X / D_Y = [(\cos \beta - \cos \beta_0)(\cos \alpha) / (\sin \beta - \sin \beta_0) + \sin \alpha] L_A / L_L \quad (A)$$

In this equation, the angles β and β_0 are greater than 0 degrees but smaller than 90 degrees, namely, $0^\circ \leq \beta_0 < \beta < 90^\circ$.

Thus, the following equations are established.

$$\cos \beta < \cos \beta_0, \text{ namely, } \cos \beta - \cos \beta_0 < 0, \text{ and}$$

$$\sin \beta > \sin \beta_0, \text{ namely, } \sin \beta - \sin \beta_0 > 0$$

On the other hand, the angle α is greater than 90 degrees ($90^\circ < \alpha$). Hence, now provided that the angle α is smaller than 180° ($\alpha < 180^\circ$) and accordingly $90^\circ < \alpha < 180^\circ$, the following relations are established.

$$\cos \alpha < 0, \sin \alpha > 0$$

Accordingly, the right side of the equation (A) is always positive, and hence the displacement D_X of the claspers 9a and 9b can be made greater than the displacement D_Y of the beam 6 by appropriately designing the angle α and the lengths L_A and L_L . In other words, the displacement D_Y of the beam 6 can be further amplified by appropriately determining the dimensions of the claspers 9a and 9b.

As a driver voltage applied to the piezoelectric element 1 is lowered, the elongation of the piezoelectric element 1 is gradually decreased. Hence, the lever arms 3a, 3b and the beam 6 are displaced in a direction opposite to the above mentioned direction, resulting in that the claspers 9a and 9b are displaced so that they are closed. In accordance with the above mentioned motion of the claspers 9a and 9b, it is possible to clamp an object with the claspers 9a and 9b by applying a driver voltage to the piezoelectric element 1 to thereby open the claspers 9a and 9b, placing an object between the claspers 9a and 9b, and then lowering a driver voltage applied to the piezoelectric element 1.

In the embodiment, a layer-laminated type piezoelectric element was used as the piezoelectric element 1. The dimensions of the beam 6 was determined as follows.

L_L : 7.54 mm

$2L_H$: 2.00 mm

$\beta_0: 6^\circ 5' 19''$

Under this specification, a driver voltage was applied to the piezoelectric element 1 to thereby obtain the elongation of $11\text{ }\mu\text{m}$. The displacement D_Y of the beam 6 was 0.30 mm . An enlargement ratio measured from the piezoelectric element 1 to the flat portion 6a of the beam 6 was 27. The angle β formed between the inclined portions 6b of the beam 6 and the X axis was $8^\circ 23' 9''$. When the length L_A of the longer portions 9d of the clampers 9a and 9b was arranged to be 15.0 mm , and the angle α formed between the longer portion 9d and the shorter portion 9c of the clampers 9a and 9b was arranged to be $99^\circ 54' 40''$, there was obtained the displacement D_X of each of the distal ends of the clampers 9a and 9b, 0.60 mm . Thus, the enlargement ratio n obtained by the clampers 9a and 9b was calculated to be 2.0 ($n = D_X/D_Y = 0.60/0.30 = 2.0$).

When the length L_A was arranged to be 30 mm , and the angle α was arranged to be $97^\circ 59' 56''$, there were obtained the enlargement ratio n of 4.0 , and the displacement D_X of 1.20 mm .

There was conducted an experiment in which the same piezoelectric element and lever arms as those of the embodiment were provided with the prior clamp device illustrated in Fig. 1, and the same driver voltage as that of the embodiment was applied to the piezoelectric element. The elongation of the piezoelectric element was $7\text{ }\mu\text{m}$, and the displacement D_X of each of the distal ends of the clampers 9a and 9b was 0.19 mm . This experimental results show that in the embodiment, the clampers 9a and 9b has a displacement-enlarged function with respect to the beam 6, and in addition, the elongation of the piezoelectric element 1 is enlarged. In the embodiment, since a only single beam is used, a load against the displacement-enlarged action of the lever arms 3a and 3b, namely a compressive force relative to the elongation of the piezoelectric element 1 is reduced to a half in comparison with a conventional piezoelectric clamp device. The increase of the elongation of the piezoelectric element 1 can be obtained due to the reduced load as above mentioned.

As having been described, the embodiment accomplishes a piezoelectric clamp device having three to six times greater open and close stroke of the clampers than that of a prior piezoelectric clamp device. By lengthen the lengths of the clampers 9a and 9b, there can be accomplished a piezoelectric clamp device having further greater open and close stroke of clampers. Since a voltage to be applied to the piezoelectric element 1 is in general in proportion to the elongation of the piezoelectric element 1, the displacement D_X of the distal ends of the clampers 9a and 9b and a clamp force with which an object is to be clamped can be adjusted to minute degree by controlling a voltage to be applied to the piezoelectric element 1. The piezoelectric clamp device may be attached to a robot hand, for instance, and used as a manipulator. The piezoelectric clamp device can be used for operation in which minute objects are to be dealt with in an evil environment such as high temperature, and irritating and hazardous gas.

Fig. 4 illustrates a variation of the above mentioned embodiment. In the embodiment illustrated in Figs. 2 and 3, the beam 6 extend in the same plane as that of a front surface 3e of the lever arms 3a and 3b, and as a result the longer portions 9d of the clampers 9a and 9b extend horizontally. However, the beam 6 may extend so that the longer portions 9d of the clampers 9a and 9b extend upwardly or downwardly. Fig. 4 illustrates the piezoelectric clamp device having the beam 6 extend in the same plane as that of a top surface 3f of the lever arms 3a and 3b, and as a result the longer portions 9d of the clampers 9a and 9b extend upwardly. The piezoelectric clamp device illustrated in Fig. 4 has the same performance as that of the device illustrated in Fig. 2.

The beam 6 may be secured to the lever arms 3a and 3b so that the longer portions 9d of the clampers 9a and 9b extend inwardly of the piezoelectric clamp device, if the lever arms 3a and 3b are long enough to avoid interference of the longer portions 9d of the clampers 9a and 9b with the substrate 5.

Figs. 5 and 6 illustrate a piezoelectric clamp device in accordance with the second embodiment of the present invention. The piezoelectric clamp device in accordance with the second embodiment is different from the first embodiment in the structure of the beam 6 and the clampers 9.

In the second embodiment, the beam 6 is configured to be bent in a direction opposite to a direction indicated with an arrow B in which buckling of the beam 6 occurs. The clampers 9a and 9b are secured to the inclined portions 6b of the beam so that the clampers 9a and 9b extend in the direction B similarly to the first embodiment. However, the angle α formed between the longer portions 9d and the shorter portions 9c and hence the beam 6 is determined to be smaller than 90 degrees unlike the first embodiment. Thus, as illustrated in Fig. 5, the clampers 9a and 9b are spaced away with each other at distal ends thereof.

Fig. 6 illustrate motion of the beam 6 and the clampers 9a and 9b as viewed from the top. As illustrated with a solid line, the beam 6 and the clampers 9a, 9b do not generate any displacement when no driver voltage is applied to the piezoelectric element 1. On the other hand, as illustrated with a broken line, the beam 6 is displaced due to the buckling thereof and accordingly the dampers 9a and 9b close when a driver voltage is applied to the piezoelectric element 1. When a driver voltage is applied to the piezoelectric element 1, the beam 6 is longitudinally compressed at opposite ends thereof in the direction A, and thus the flat portion 6a of the beam 6 is displaced in the direction B with a length thereof remaining unchanged.

In the second embodiment, the enlargement ratio obtained by the clampers 9a and 9b is determined in accordance with the equation (A).

$$n = D_x/D_y = [(\cos \beta - \cos \beta_0)(\cos \alpha)/(\sin \beta - \sin \beta_0) + \sin \alpha] L_A/L_L \quad (A)$$

As a driver voltage applied to the piezoelectric element 1 is lowered, the elongation of the piezoelectric element 1 is gradually decreased. Hence, the lever arms 3a, 3b and the beam 6 are displaced in a direction opposite to the above mentioned direction, resulting in that the claspers 9a and 9b are displaced so that they are open. In accordance with the above mentioned motion of the claspers 9a and 9b, it is possible to release an object which was clamped with the claspers 9a and 9b by applying a driver voltage to the piezoelectric element 1 to thereby clamp an object between the claspers 9a and 9b, and then lowering a driver voltage applied to the piezoelectric element 1.

Thus, the piezoelectric clamp device in accordance with the second embodiment provides just the opposite motion to that of the first embodiment. Thus, the piezoelectric clamp device in accordance with the first or second embodiment may be used in accordance with necessity.

Claims

1. A piezoelectric clamp device comprising a piezoelectric element (1) to be elongated in a direction in accordance with a voltage applied thereto, arms (3a, 3b) for enlarging elongation of the piezoelectric element (1) by the principles of the lever and fulcrum, beams for further enlarging the elongation of the piezoelectric element (1) enlarged by the arms (3a, 3b), by the principle of buckling, and a pair of claspers (9a, 9b) attached to the beams in facing relation for opening and closing in accordance with motion of the beams, the piezoelectric clasper characterized by:
 - a single beam (6) in place of the beams to reduce a load to be exerted on the arms (3a, 3b) when the arms (3a, 3b) displace due to the elongation of the piezoelectric element (1); and
 - the claspers (9a, 9b) extending at an angle (α) from an axis along which buckling of the beam (6) occurs, the claspers (9a, 9b) further enlarging the elongation of the piezoelectric element (1).
2. The piezoelectric clamp device as recited in claim 1, wherein the beam (6) is bent in a direction B in which buckling of the beam (6) occurs.
3. The piezoelectric clamp device as recited in claim 2, wherein the beam (6) is composed of a strip comprising a flat zone (6a) disposed at the center thereof and in parallel with the direction A and inclined zones (6b) disposed at opposite sides of the flat zone (6a), and wherein each of the claspers (9a, 9b) is attached to each of the inclined zones (6b).
4. The piezoelectric clamp device as recited in claim 3, wherein the angle (α) is than greater 90 degrees when the claspers (9a, 9b) extend in the direction B, while smaller than 90 degrees when the claspers (9a, 9b) extend in a direction opposite to the direction B, the angle (α) being defined as an angle between the beam (6) and one of outer surfaces of the claspers (9a, 9b).
5. A piezoelectric clamp device comprising: a substrate (5) having high rigidity and at least two sides facing to each other; a pair of lever arms (3a, 3b) each of which is connected to the side of the substrate (5) through a hinge (4a, 4b) which partitions the lever arms (3a, 3b) into a longer portion (3c) and a shorter portion (3d); a piezoelectric element (1) connected at opposite ends thereof to the shorter portions (3c) of the lever arms (3a, 3b) through a hinge (2a, 2b); beams fixedly connected at opposite ends thereof to the longer portions (3c) of the lever arms (3a, 3b); and a pair of claspers (9a, 9b) attached to the beams in facing relation for opening and closing in accordance with motion of the beams, the piezoelectric clasper characterized by:
 - a single beam (6), substituted for the beams, to reduce a load to be exerted on the arms (3a, 3b) when the arms (3a, 3b) displace due to the elongation of the piezoelectric element (1), the beam extending in a direction A in which the longer portions (3c) of the lever arms (3a, 3b) displace; and
 - the claspers (9a, 9b) extending at an angle (α) from an axis along which buckling of the beam (6) occurs, the claspers being attached to the beam (6) so that the claspers open and close in said direction A, the claspers (9a, 9b) further enlarging the elongation of the piezoelectric element (1).
6. The piezoelectric clamp device as recited in claim 5, wherein the beam (6) is bent in a direction B in which buckling of the beam (6) occurs.
7. The piezoelectric clamp device as recited in claim 6, wherein the beam (6) is composed of a strip comprising a flat zone (6a) disposed at the center thereof and in parallel with the direction A and inclined zones (6b) disposed at opposite sides of the flat zone (6a), and wherein each of the claspers (9a, 9b) is attached to each of the inclined zones (6b).

8. The piezoelectric clamp device as recited in claim 7, wherein the angle (α) is than greater 90 degrees when the clampers (9a, 9b) extend in the direction B, while smaller than 90 degrees when the clampers (9a, 9b) extend in a direction opposite to the direction B, the angle (α) being defined as an angle between the beam (6) and one of outer surfaces of the clampers (9a, 9b).

5

10

15

20

25

30

35

40

45

50

55

FIG.1
PRIOR ART

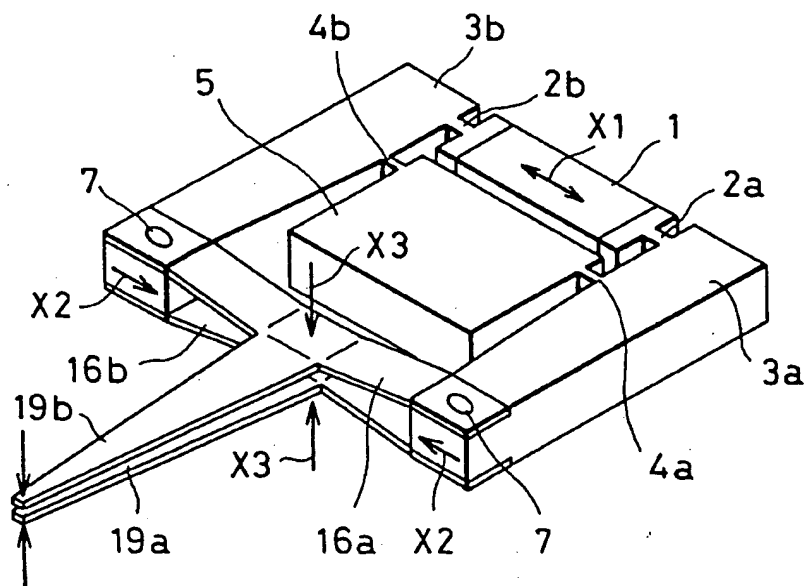


FIG. 2

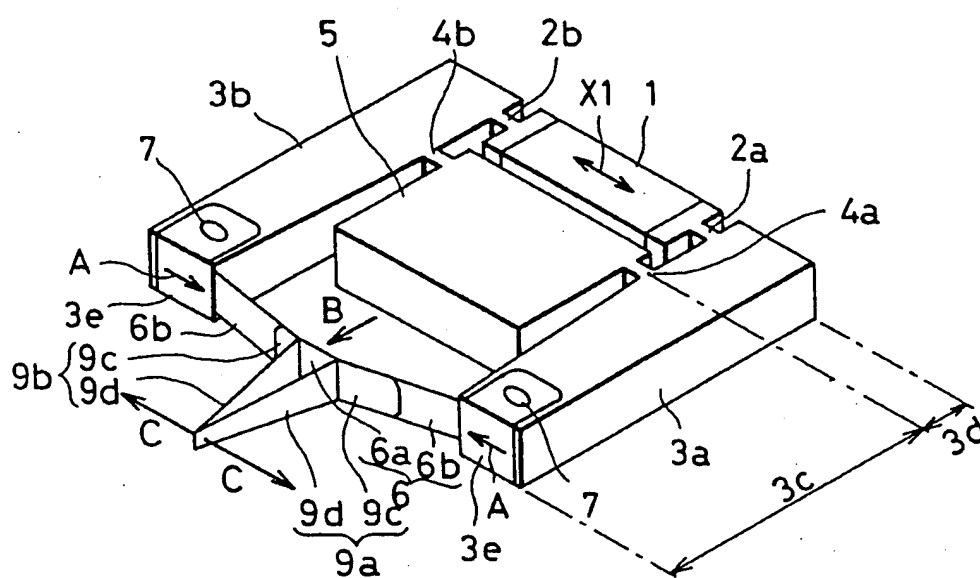


FIG.3

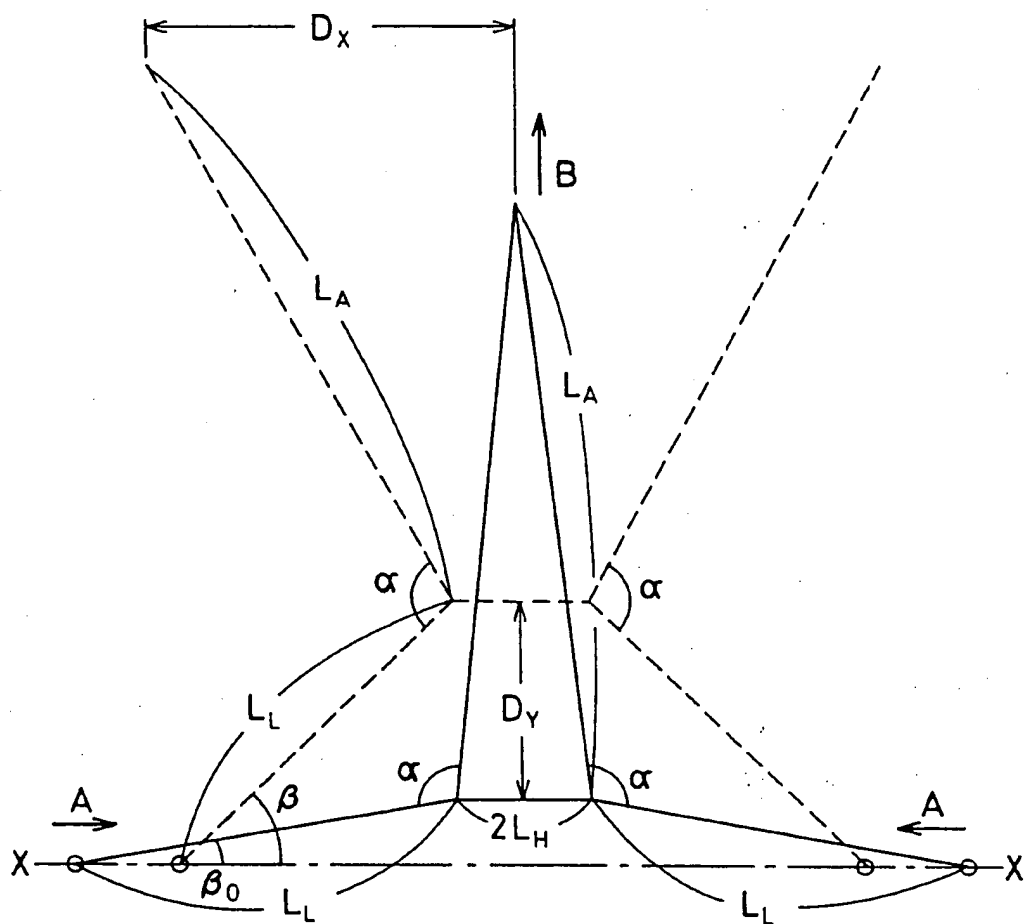


FIG. 5

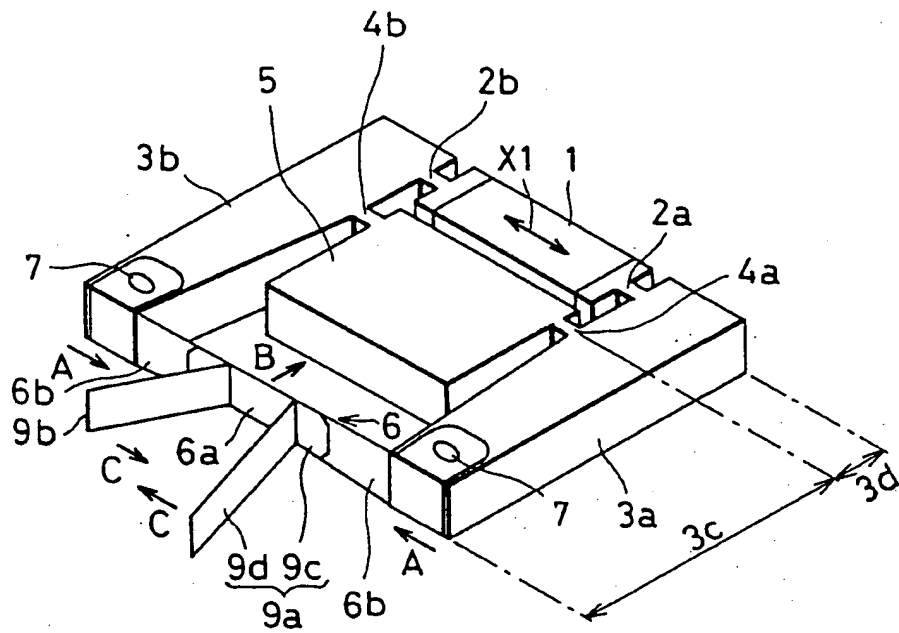
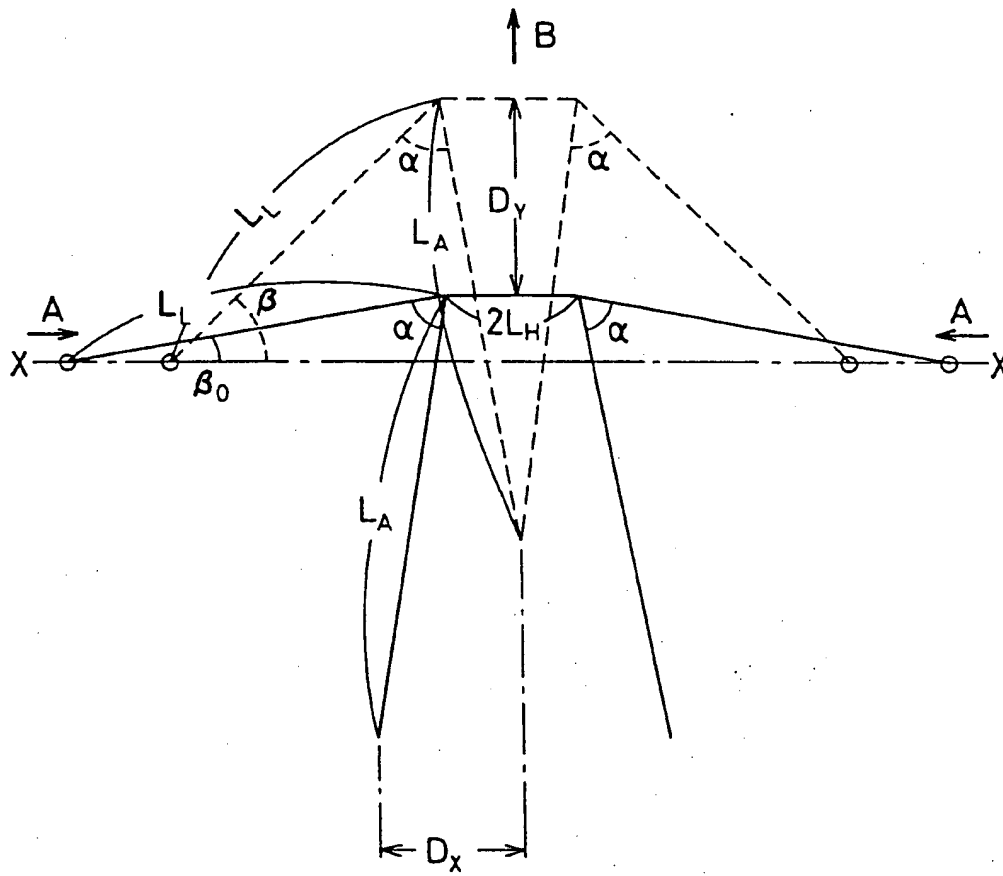


FIG. 6





European Patent
Office

EUROPEAN SEARCH REPORT

Application Number
EP 95 11 4244

DOCUMENTS CONSIDERED TO BE RELEVANT			
Category	Citation of document with indication, where appropriate, of relevant passages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (Int.Cl.6)
A	EP-A-0 320 996 (NIPPON ELECTRIC CO) 21 June 1989 * abstract; figure 9 * ---	1	H01L41/09
A	US-A-5 270 984 (MINE KAZUHIRO) 14 December 1993 * abstract; figure 1 * -----	1	
			TECHNICAL FIELDS SEARCHED (Int.Cl.6)
			H01L
The present search report has been drawn up for all claims			
Place of search THE HAGUE		Date of completion of the search 12 January 1996	Examiner Pelsers, L
<p>CATEGORY OF CITED DOCUMENTS</p> <p>X : particularly relevant if taken alone Y : particularly relevant if combined with another document of the same category A : technological background O : non-written disclosure P : intermediate document</p> <p>T : theory or principle underlying the invention E : earlier patent document, but published on, or after the filing date D : document cited in the application L : document cited for other reasons * : member of the same patent family, corresponding document</p>			

EPO FORM 1503 01/92 (P0400)